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To: Commissioner for Patents	Total Pages Sent: 8
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Facsimile Number: (571) 273-8300	Transmission Date: January 29, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wunnicke, *et al.* Docket No.: INF-138
Serial No: 10/781,920 Art Unit: 1756
Date Filed: February 20, 2004 Examiner: Brittany L. Raymond
Title: Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates

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- Certification of Facsimile Transmission (1 page)
- Amendment (7 pages)

Respectfully submitted,

Nancy Milinkovich
Legal Assistant

Confirmation Respectfully Requested

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed November 3, 2006. Please amend the above-referenced application as follows.